



Review of Micro-Propulsion Ablative Devices



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Outline

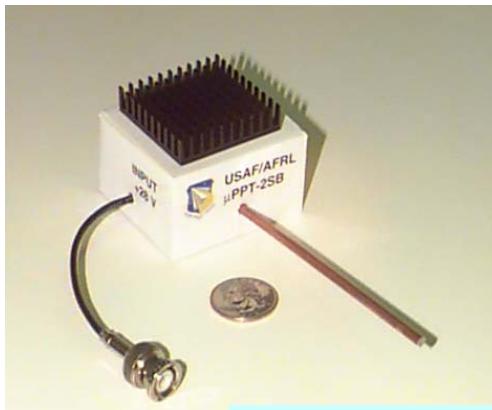
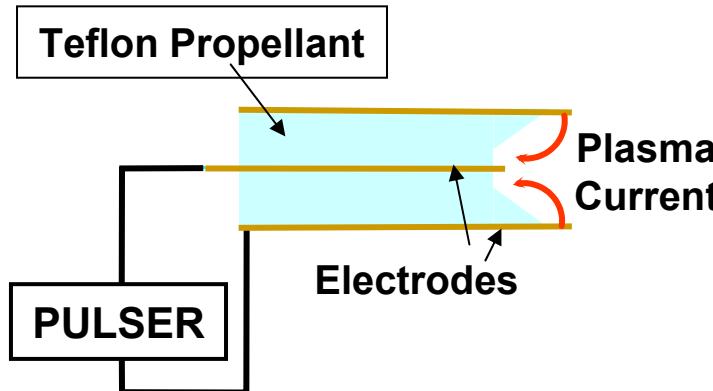
- Examples of micro propulsion ablative devices
- Fundamentals of ablation
- Detailed analysis of specific devices
 - Micro-Pulsed Plasma Thruster
 - Micro-Laser Plasma Thruster
 - Micro-Vacuum Arc Thruster
- Summary and Future Needs



Micro-Pulsed Plasma Thruster (AFRL)



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MicroPPTs

Istanbul, Turkey, June 2004

100 grams
Energy 1-10 J
Thrust-to-Power 1-10 μ N/W
Simple Engineering

Ablation rate:
10 cm in 100 hour, 1 Hz

FalconSat

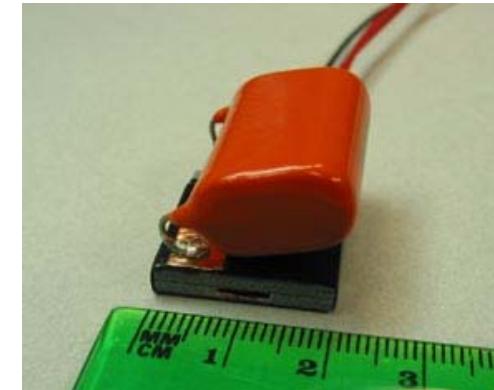
US Air Force Academy, 2005
<100-kg class



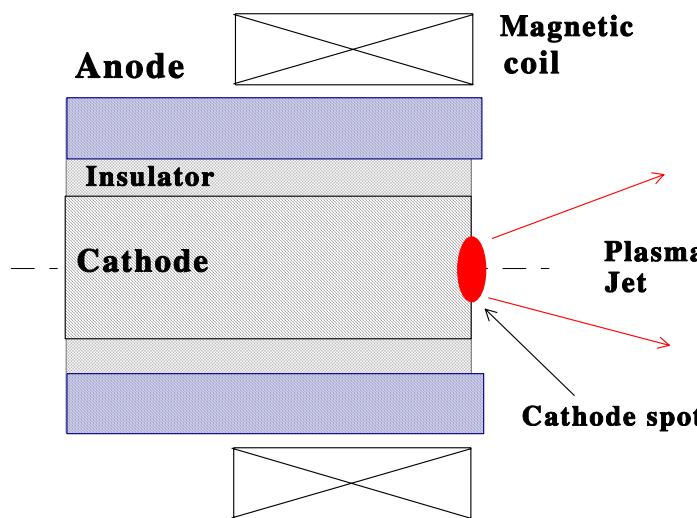
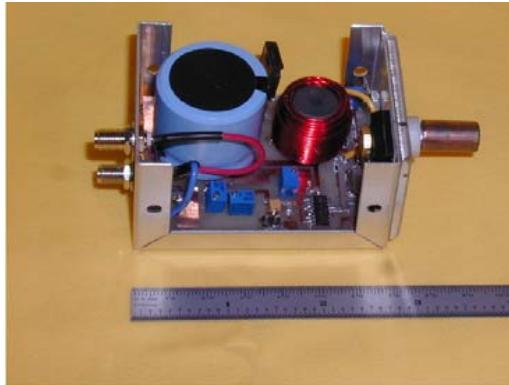
Micro-PPT Technology Development (JHU-APL)

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- APL exploring fundamental effects associated with device scaling
- Examining influence of energy deposition and electrode geometry upon electro-mechanical response
- Developing novel techniques for micro-PPT device characterization



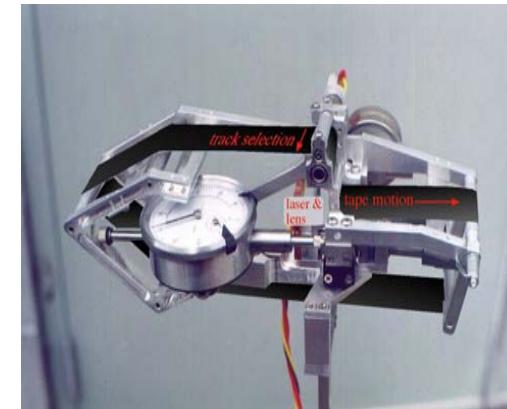
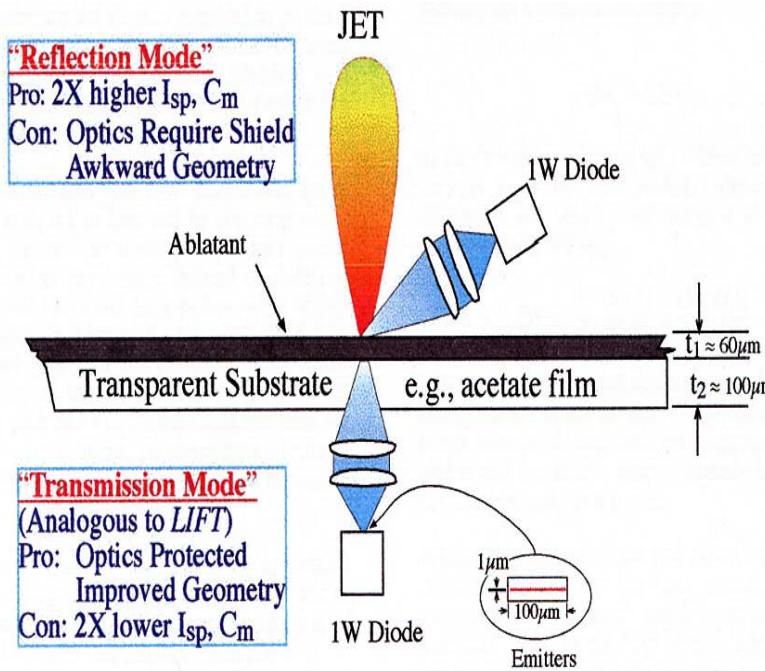
Micro-Vacuum Arc Thruster (AASC)



Inductive energy storage PPU
(efficiency of the PPU >90%)
Low mass (<300g)
Typical current ~100 A
Voltages of ~25-30 V.
Total efficiency ~10%
 $I_{sp} \sim 1000-3000$ s
 $T/P \sim 10 \mu N/W$

Micro-Laser Plasma Thruster

- micro Laser-ablation Plasma Thruster, μ -LPT (Photonics Associates).
- micro chip Laser-ablation Plasma Thruster, (Lincoln Lab).



Power: 2-14 W

Pulse duration: 3-10 ms

Q^* : $2 \times 10^7 \text{ J/kg}$

C_w : $60-100 \mu\text{N/W}$

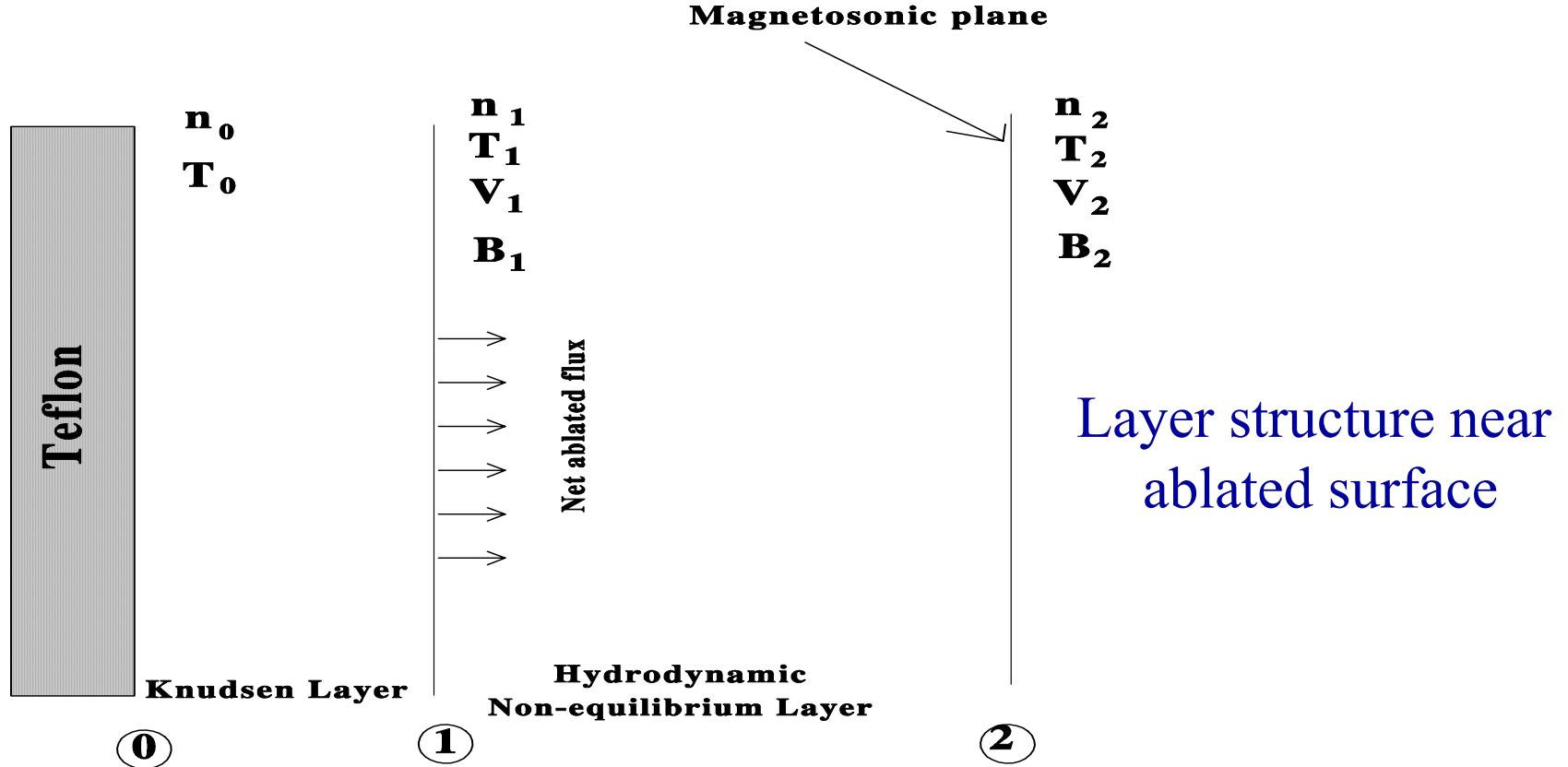
I_{sp} : $300-1000 \text{ s}$



Ablation Fundamentals



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Kinetic model of the Knudsen Layer (1)

Analytical and particle (DSMC) approaches:

$$f(x, \mathbf{V}) = \xi(x)f_1(\mathbf{V}) + (1 - \xi(x))f_2(\mathbf{V})$$

where $\xi(x=0)=1$ and $\xi(L)=0$ with $x=0$

[Mott-Smith, 1951]

$$f_1(\mathbf{V}) = n_0 \beta^{3/2} \exp(-V_x^2) \quad V_x > 0$$

$$f_1(\mathbf{V}) = \delta f_2(\mathbf{V}) \quad V_x < 0$$

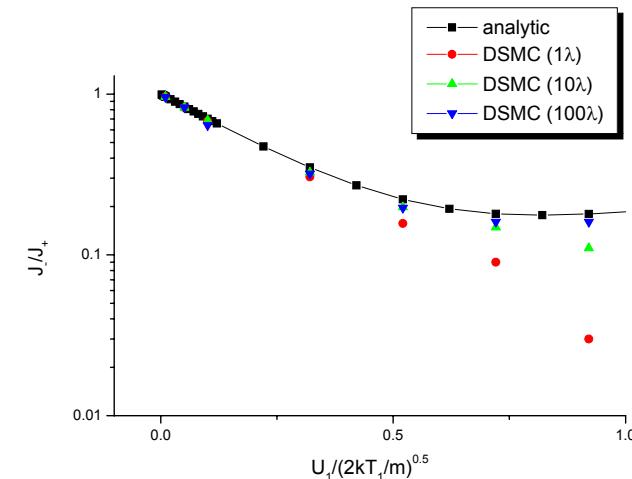
$$f_2(\mathbf{V}) = n_1 \beta^{3/2} \exp(-(v - U)^2)$$

[Anisimov, 1968]

$$\int V_x f(V) dV = \text{const} \quad (\text{mass})$$

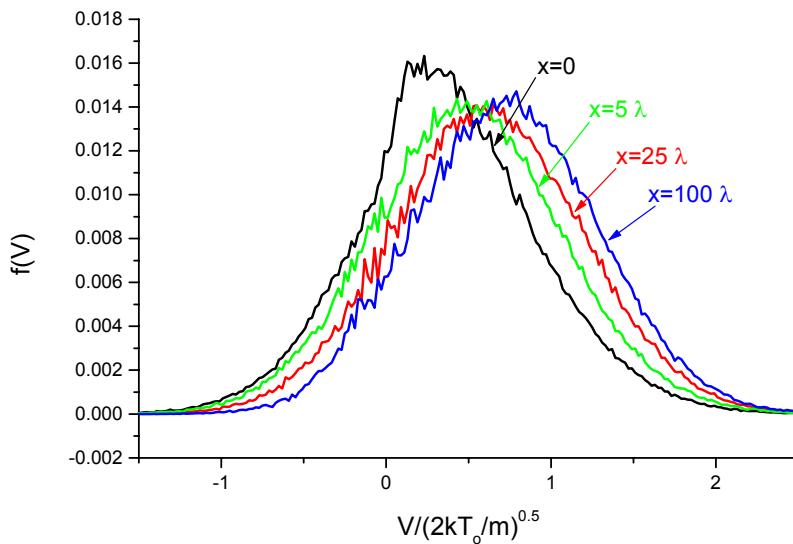
$$\int V_x^2 f(V) dV = \text{const} \quad (\text{momentum})$$

$$\int V_x V^2 f(V) dV = \text{const} \quad (\text{energy})$$

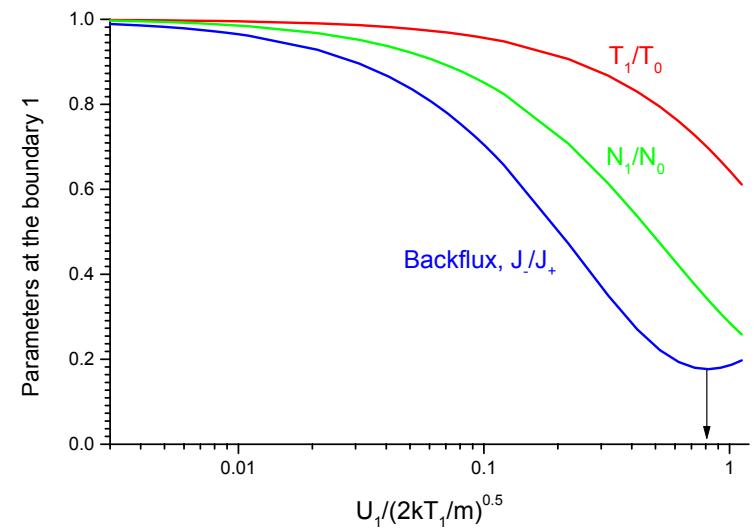


Kinetic model of the Knudsen Layer (2)

Particle distribution function. DSMC



Parameters at the Knudsen layer edge



Hydrodynamic Layer

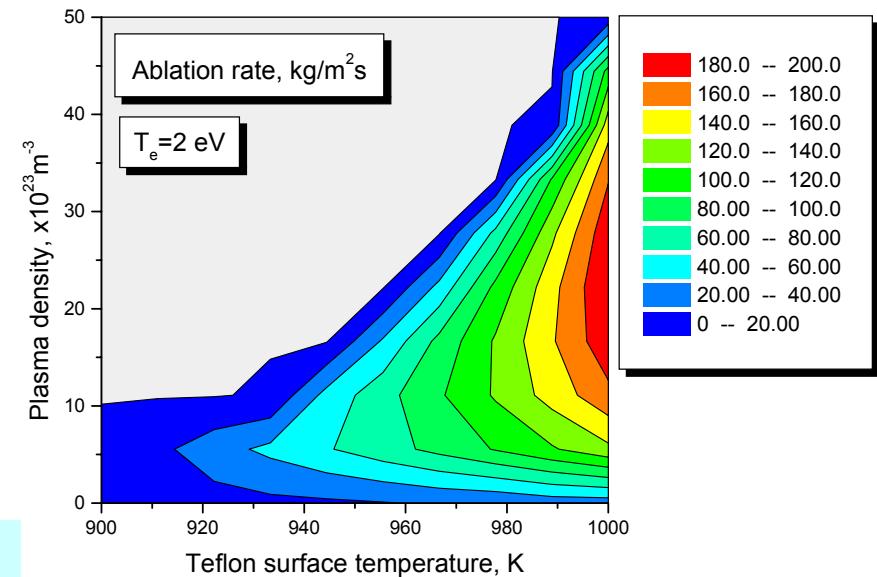
$$d(nV) = 0$$

$$M(nV) \frac{dV}{dx} = - \frac{d(nkT)}{dx} + j \times B$$

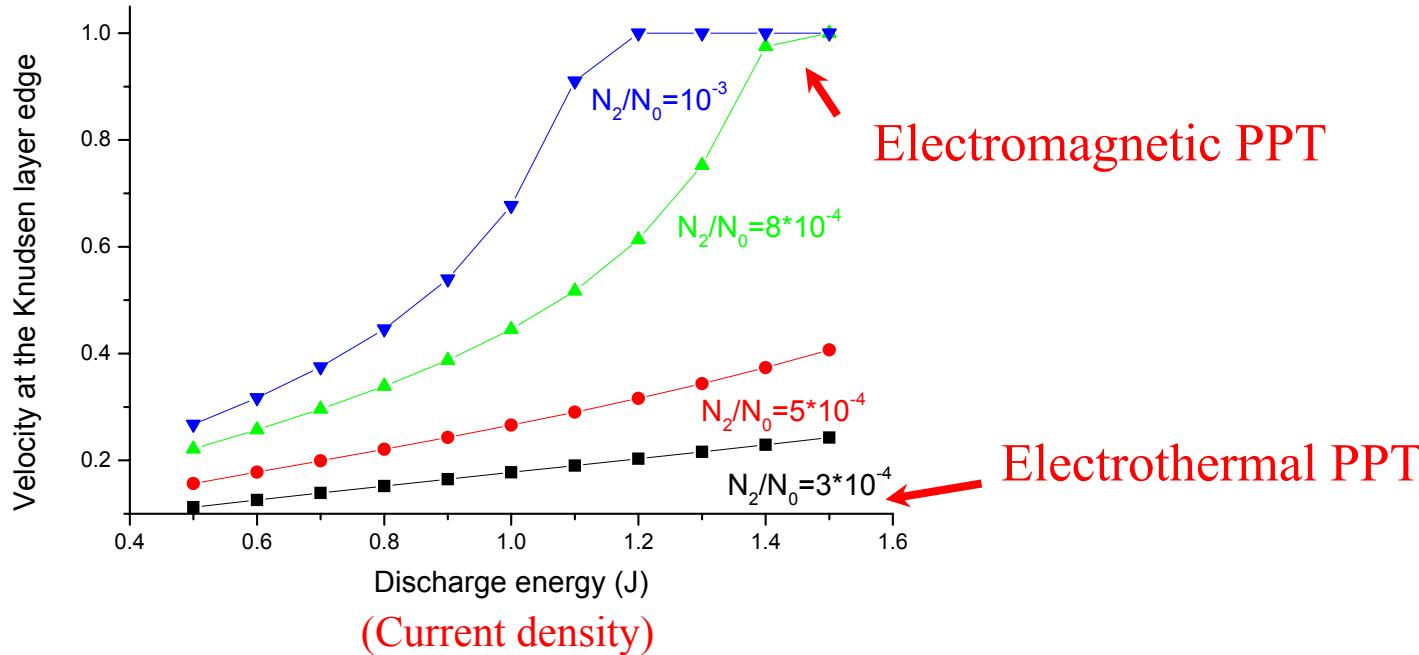
$$\frac{MV_1^2}{2kT_1} = \frac{\frac{n_1}{2} - \frac{T_2 n_2}{2T_1} + \frac{1}{4} \cdot \frac{\mu(jd)^2}{kT_1}}{\frac{3}{2} \cdot \frac{n_1^2}{n_2} - n_1}$$

V_1 depends on the specifics of acceleration (n_2, j)

Example: electrothermal thruster

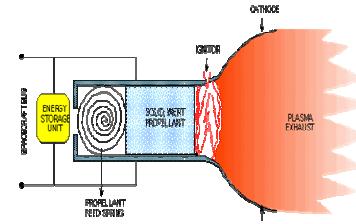


Velocity at the Knudsen Layer Edge

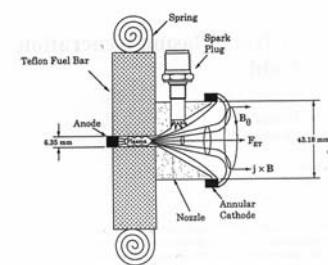


Electromagnetic acceleration leads to transition to vacuum evaporation regime

In addition to acceleration mechanism PPTs can be classified by ablation mode

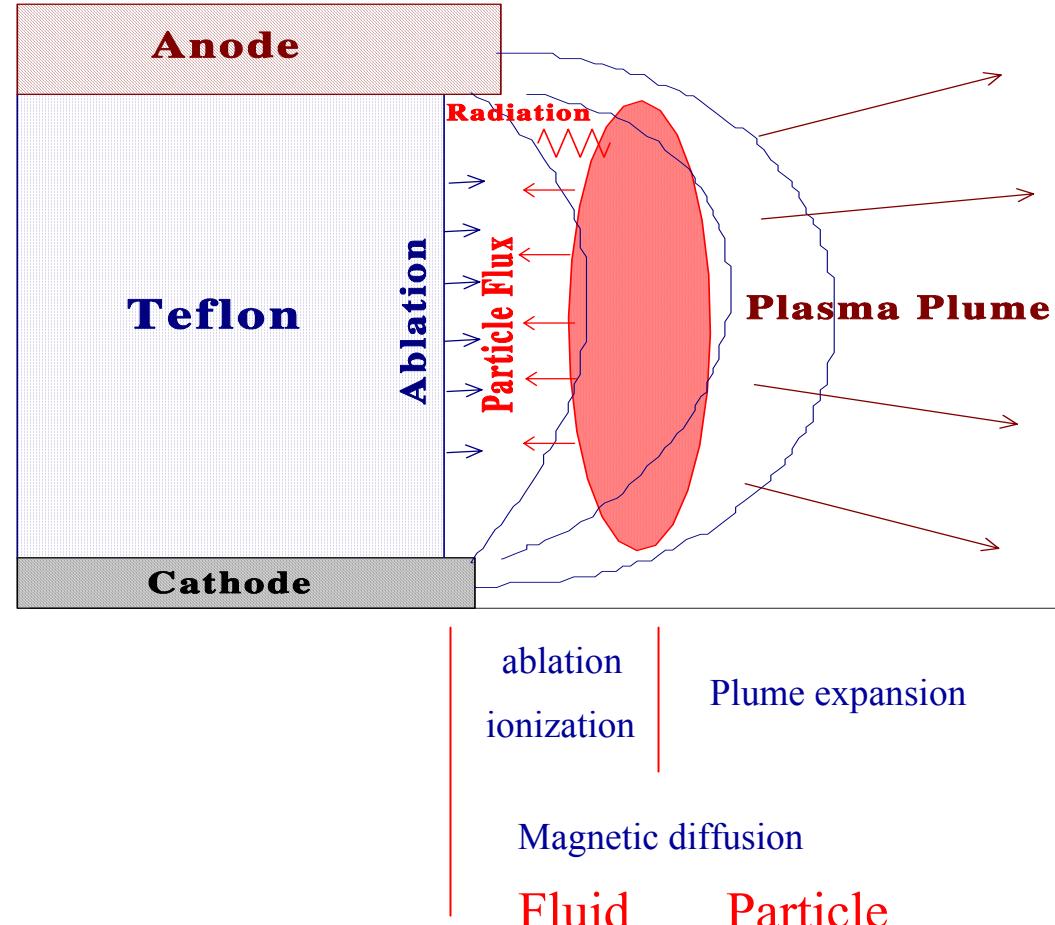


Mikellides *et al*



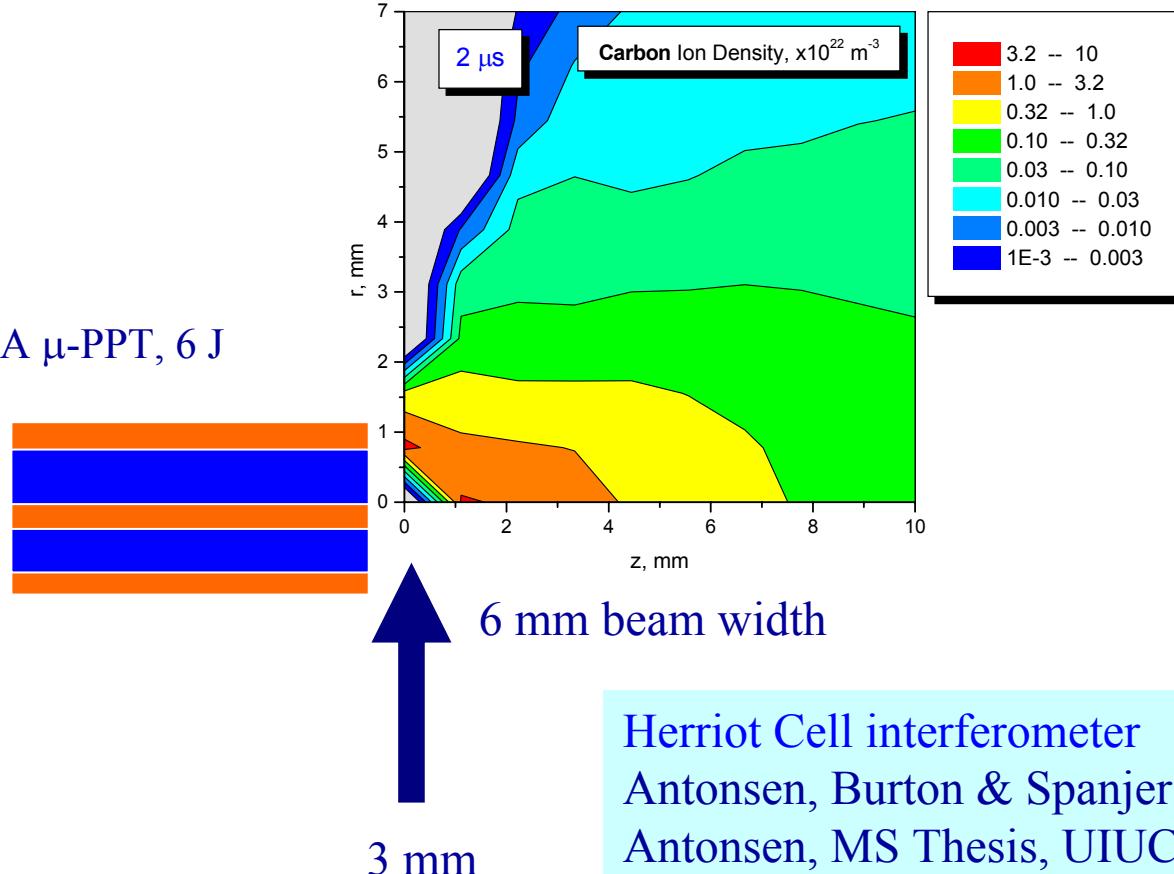
Keidar *et al* 2000

End-to-end simulation



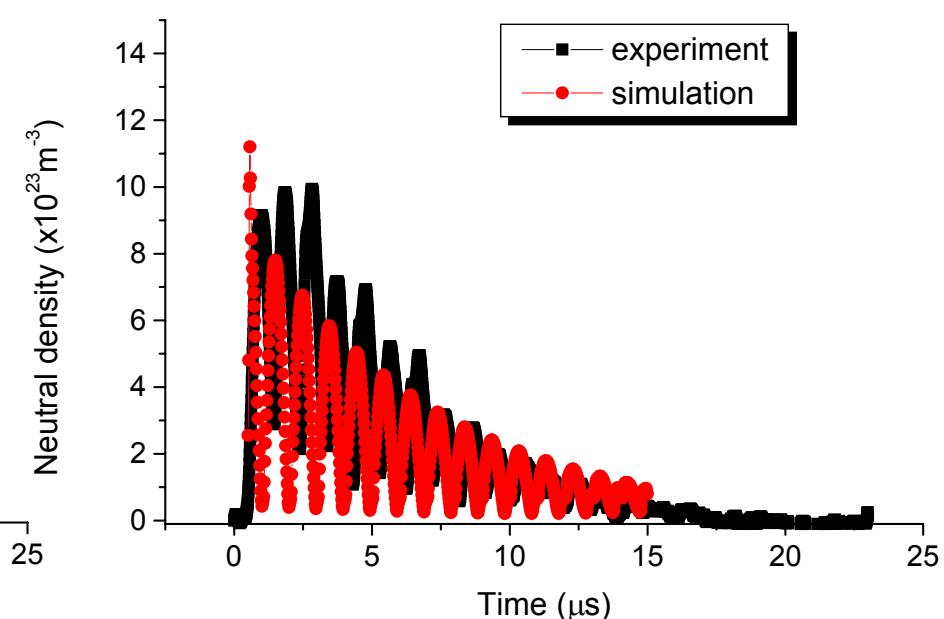
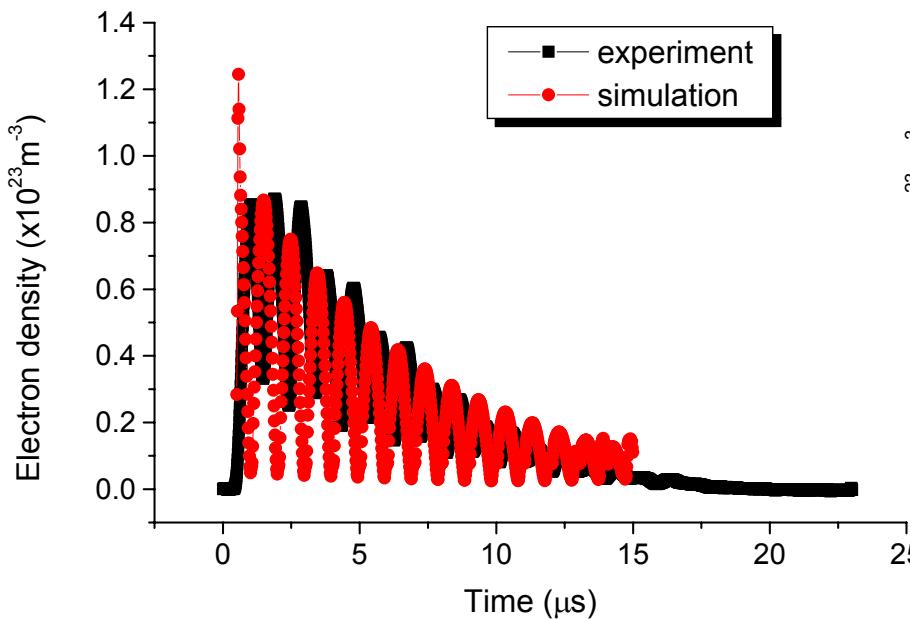
Comparison with experiment (1)

1/4" DIA μ -PPT, 6 J



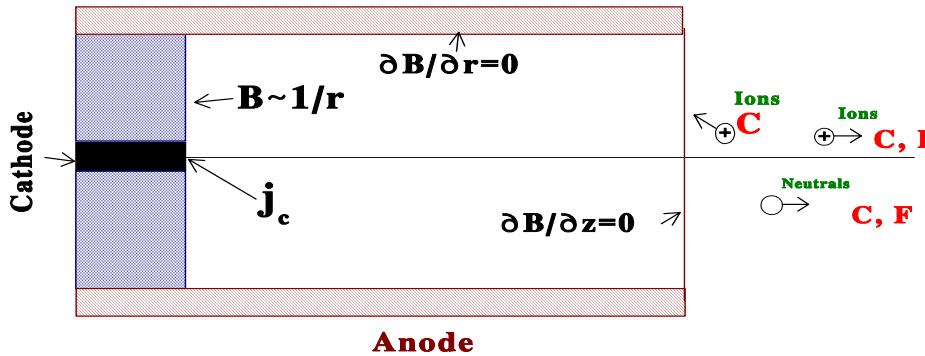
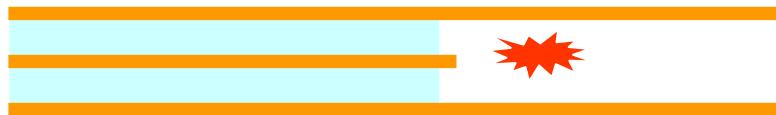
Comparison with experiment (2)

1/4" DIA μ -PPT, 6 J



Self-consistent non-equilibrium ionization model

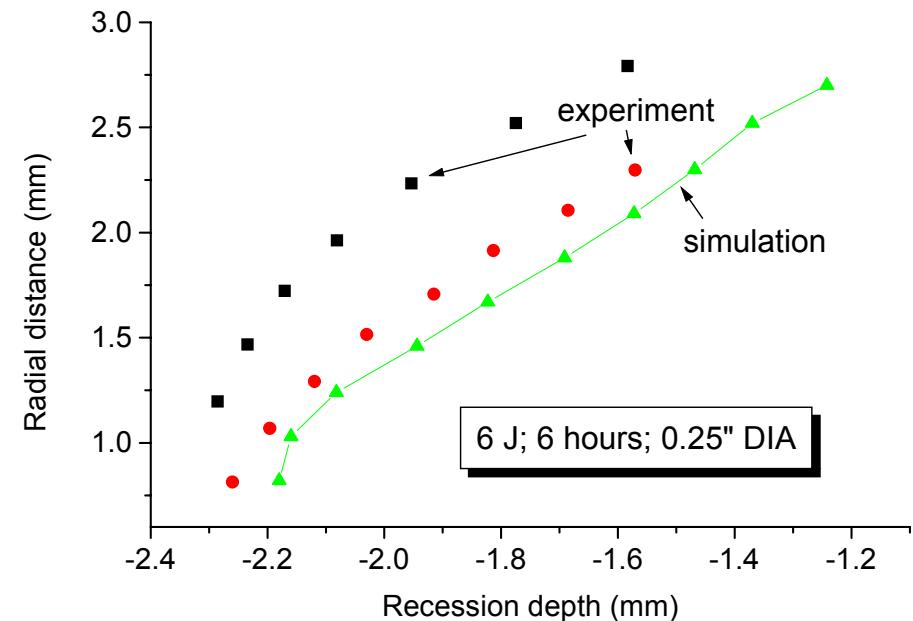
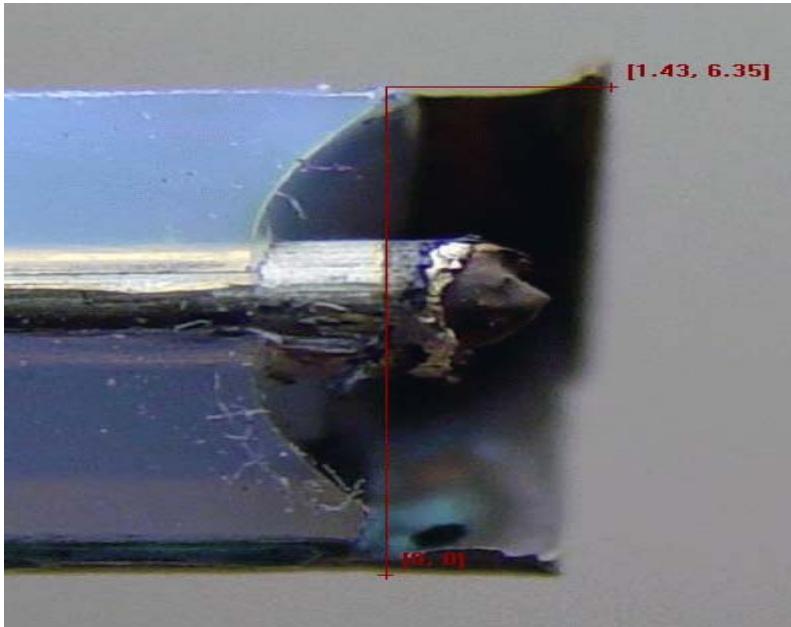
Propellant recession (1)



- 2D PIC-DSMC model & magnetic transport
 - time-dependent boundary conditions
 - plasma layer model
- magnetic field & current distribution (energy balance & ion dynamics)
- collisions (elastic & non-elastic)

Propellant recession (2)

1/4" DIA, 6 J
6 hours, 1Hz

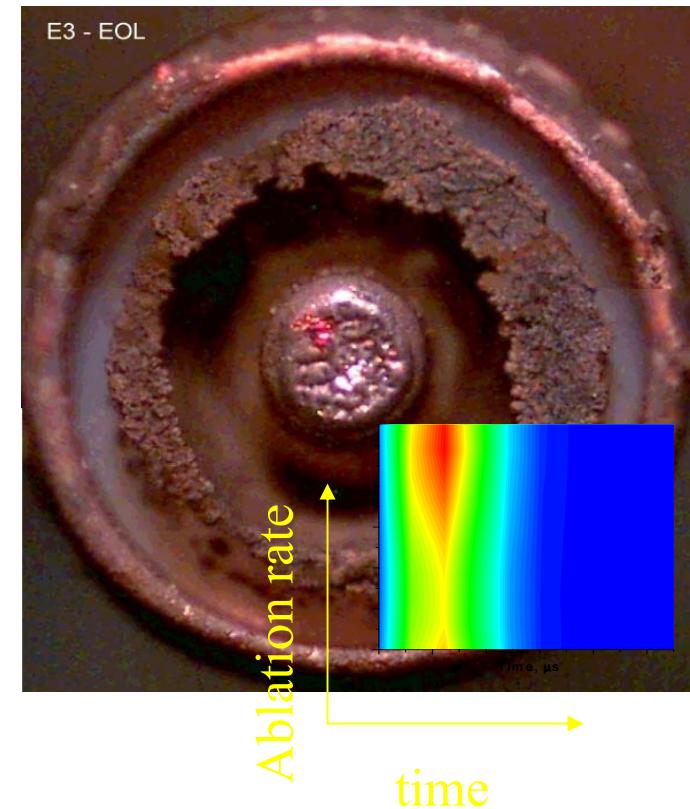




Ablation pattern: Charring

Ablation rate calculations are based on plasma layer model and ablation theory

AFRL Experiment:
Tests agree with model –
Cold thrusters char easier

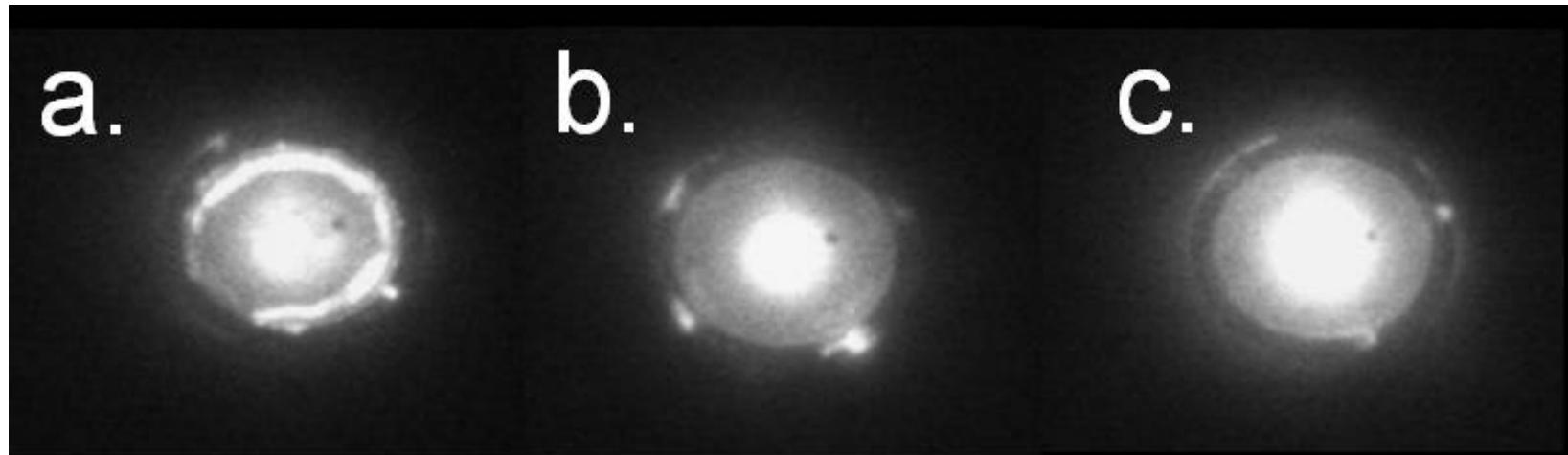




Discharge non-uniformity

High speed camera
visible emission

Arc spoking increases with energy



2.30 J

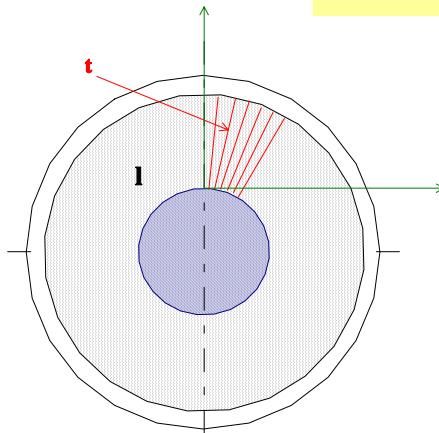
5.55 J

6.73 J

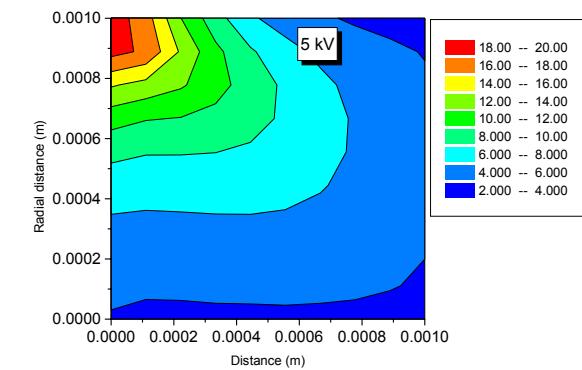
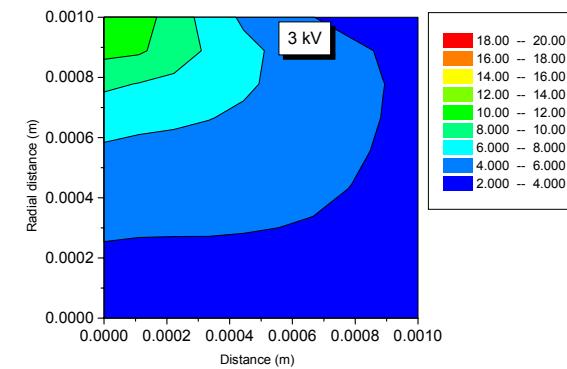
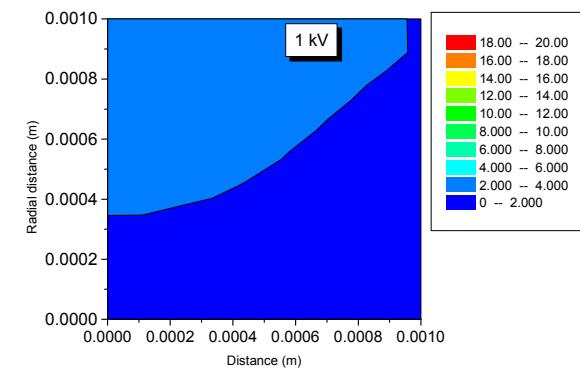


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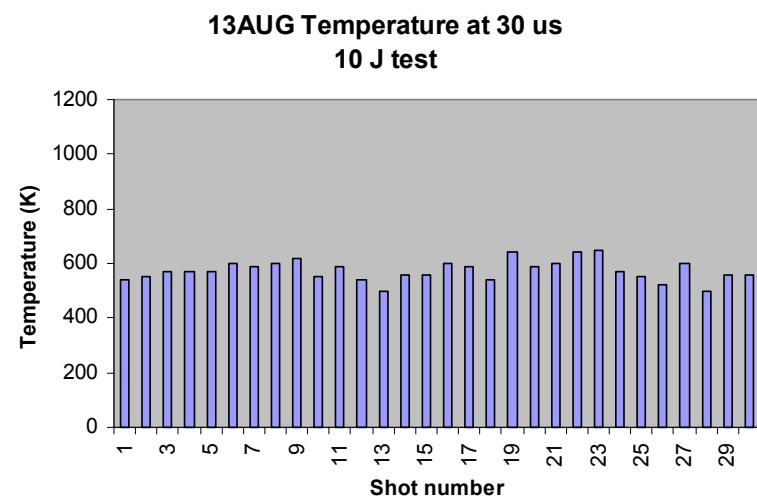
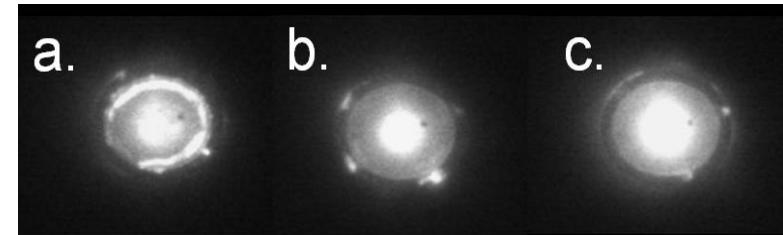
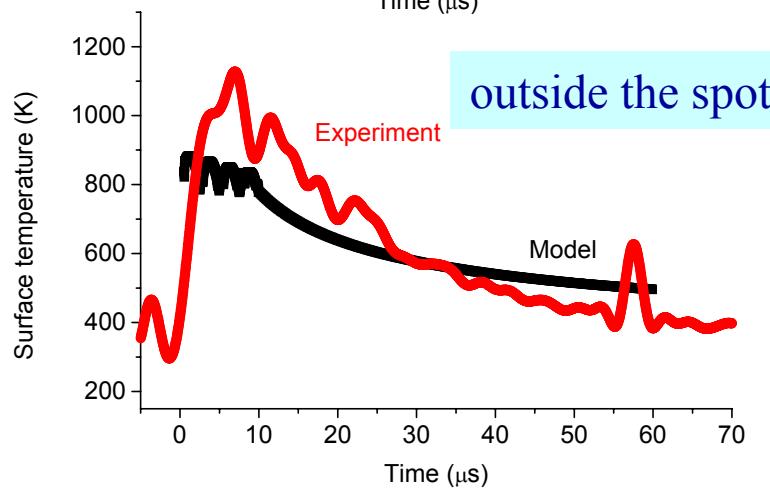
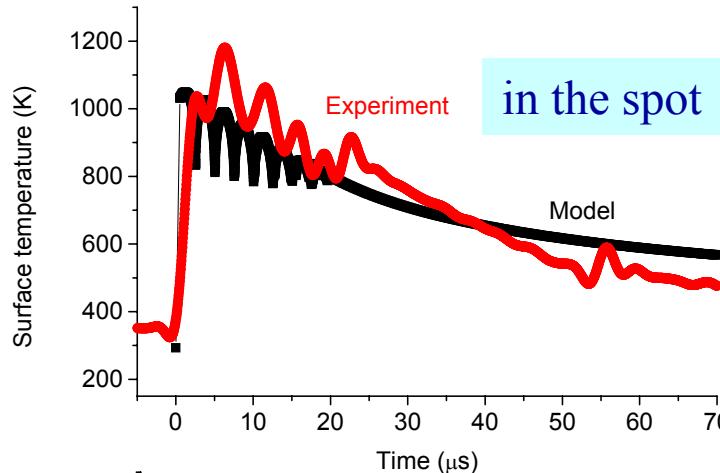
Current constriction modeling



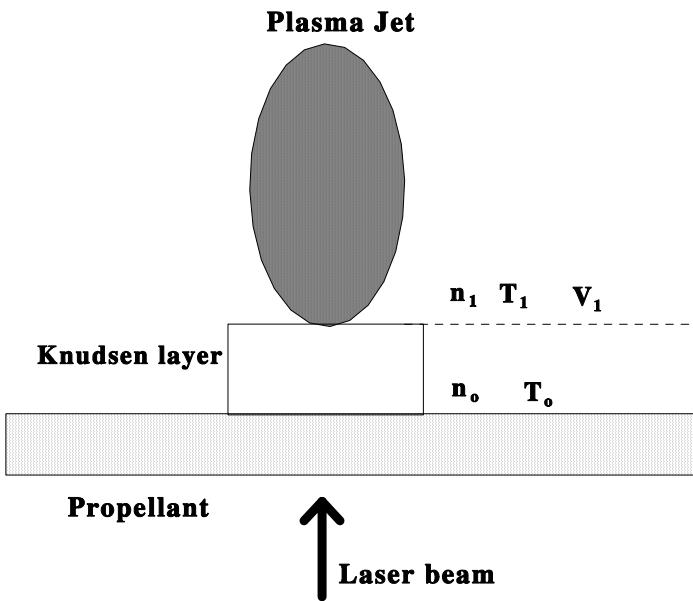
Two-fluid MHD Calculated current density (normalized)



Surface temperature (1)



Micro-Laser Plasma Thruster



- Energy equations:

$$\frac{3}{2}n_e V \partial T_p / \partial x = Q_{IB} - Q_{ei} - Q_\lambda$$

- Dominated by inverse-Bremsstrahlung

$$Q_{IB} = \alpha_{IB} I_0 \exp(-\alpha_{IB} x)$$

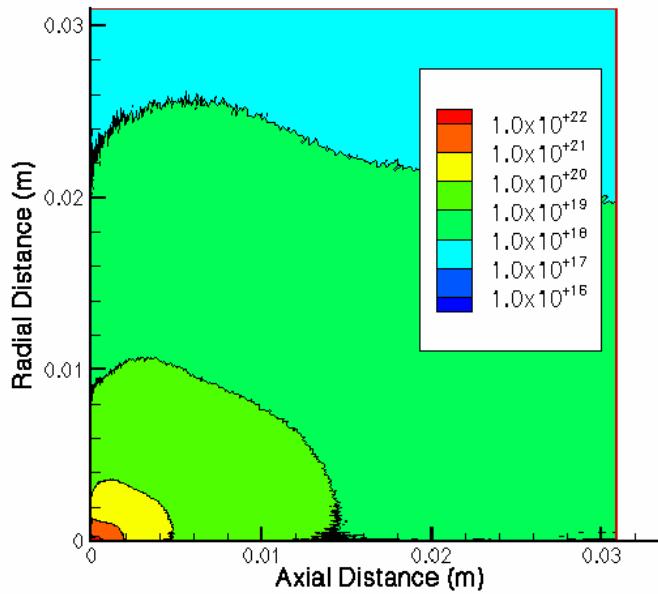
$$\alpha_{IB} = 1.37 \times 10^{-35} \lambda^3 N_e^2 T_e^{-\frac{1}{2}}$$

- Plasma properties:

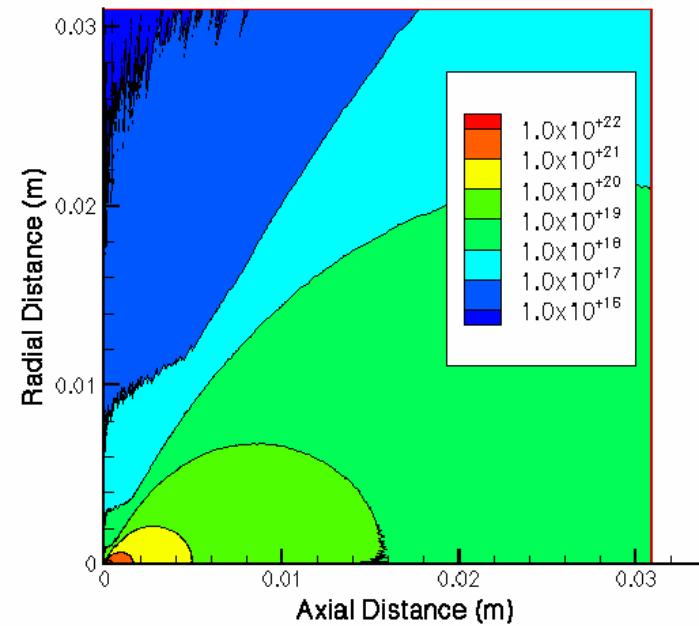
- composition (C, H, C⁺, H⁺, Cl)
- assuming LTE

Plume Simulation (PIC-DSMC)

$P=6.5 \times 10^{-5}$ torr



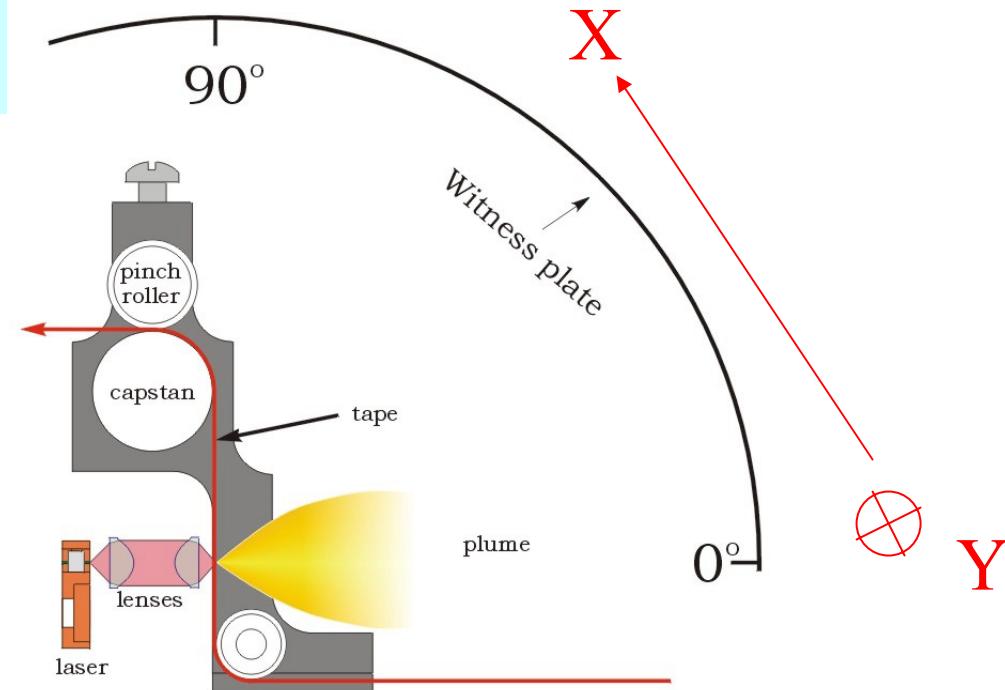
vacuum



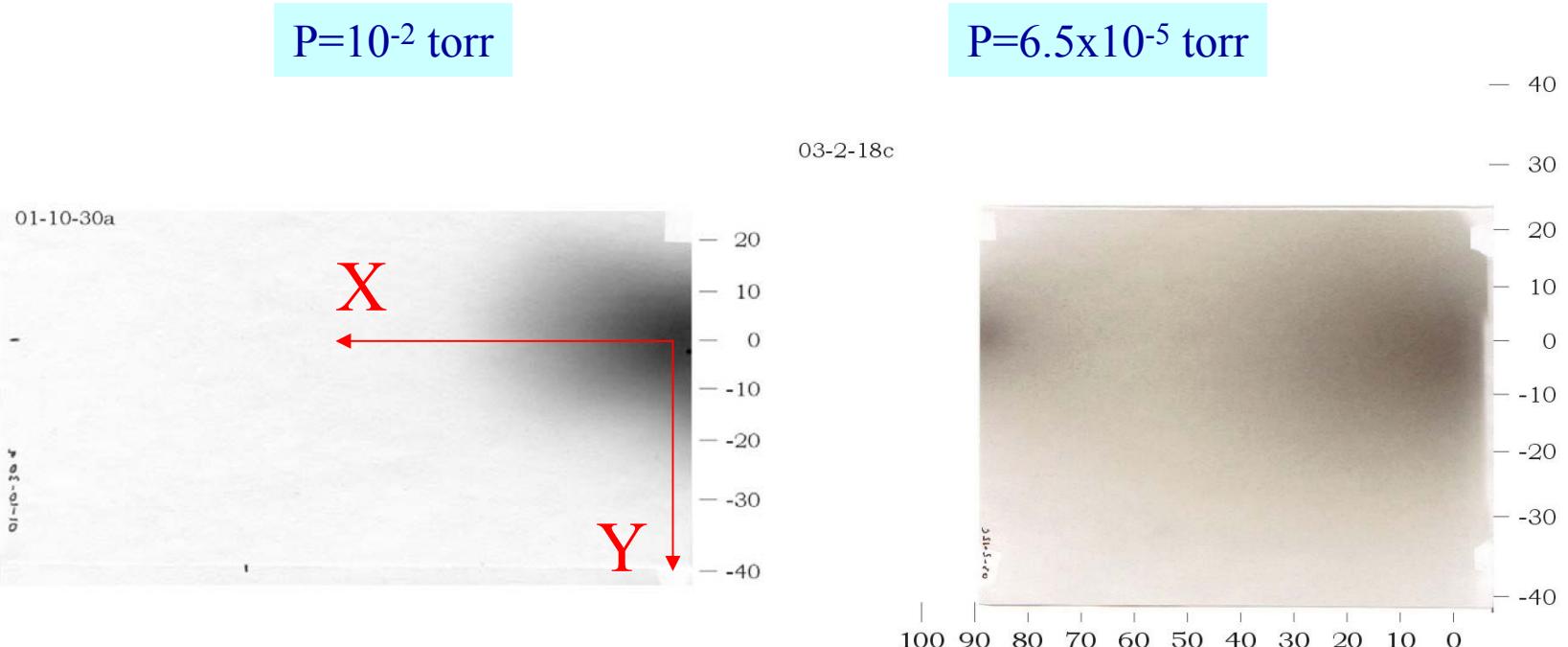
8 W

Comparison with experiment (1)

Experimental set up
Witness plate deposition



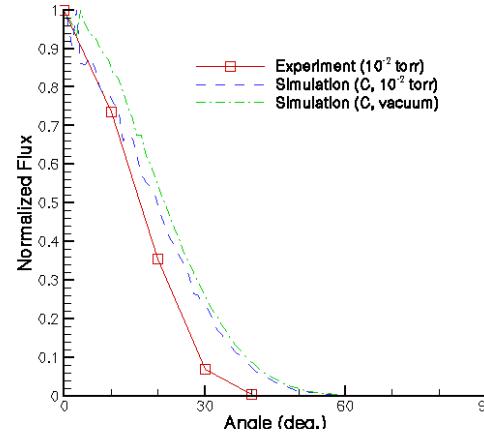
Comparison with experiment (2)



SEM analysis shows that deposition material is carbon
Thus carbon flux is compared with deposition profiles

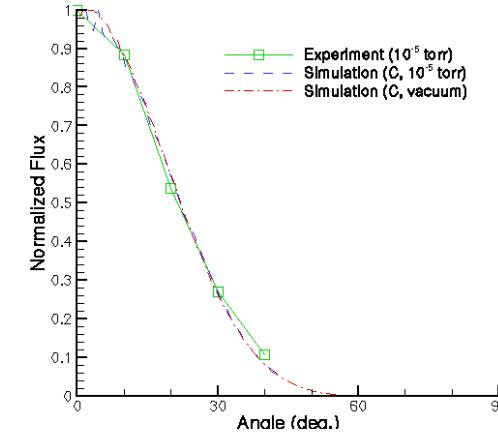
Comparison with experiment (3)

2.5 W; P=10⁻² torr

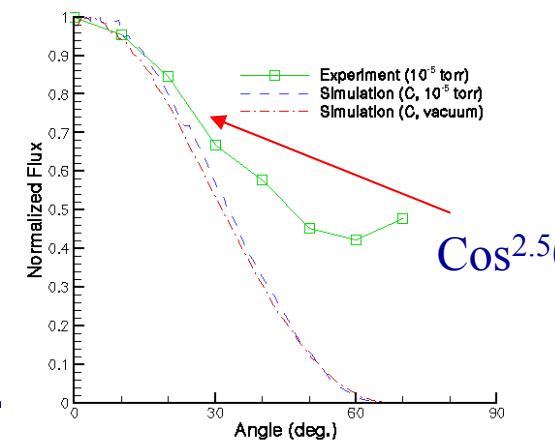
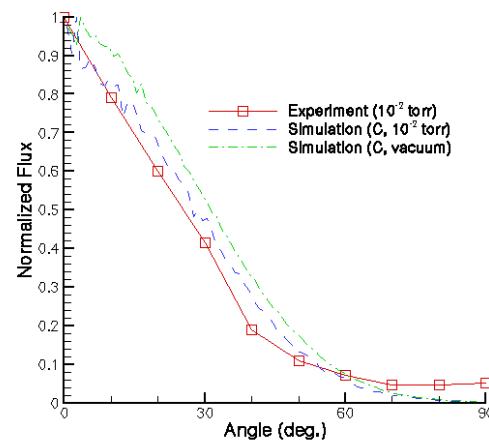


X

8 W; P=6.5x10⁻⁵ torr



Y



Istanbul, Turkey, June 2004

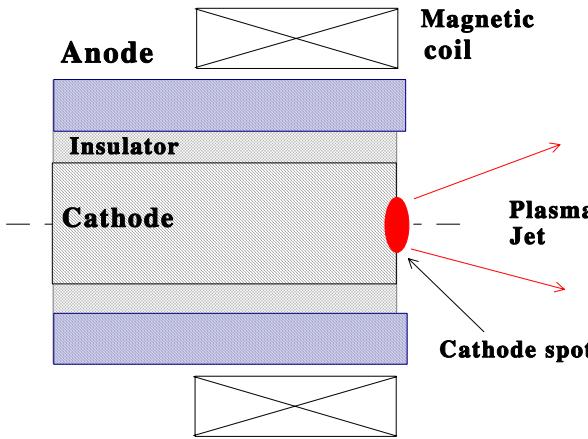
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Micro-Vacuum Arc Thruster

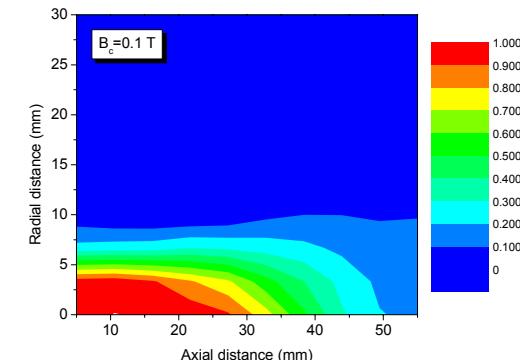
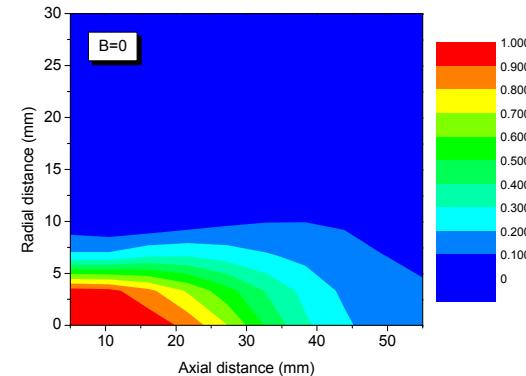


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MHD free boundary model

$$\begin{aligned} m_i (\mathbf{V}_i \cdot \nabla) \mathbf{V}_i &= -k(Z_i T_e + T_i) \cdot \nabla \ln(n) + \mathbf{j} \times \mathbf{B} / n \\ \mathbf{j} &= \sigma \{ \mathbf{E} + (k T_e / e) \cdot \nabla \ln(n) - \mathbf{j} \times \mathbf{B} / (en) + (\mathbf{V}_i \times \mathbf{B}) \} \\ \nabla \cdot (\mathbf{V}_i n) &= 0 \\ \nabla \cdot \mathbf{j} &= 0 \end{aligned}$$

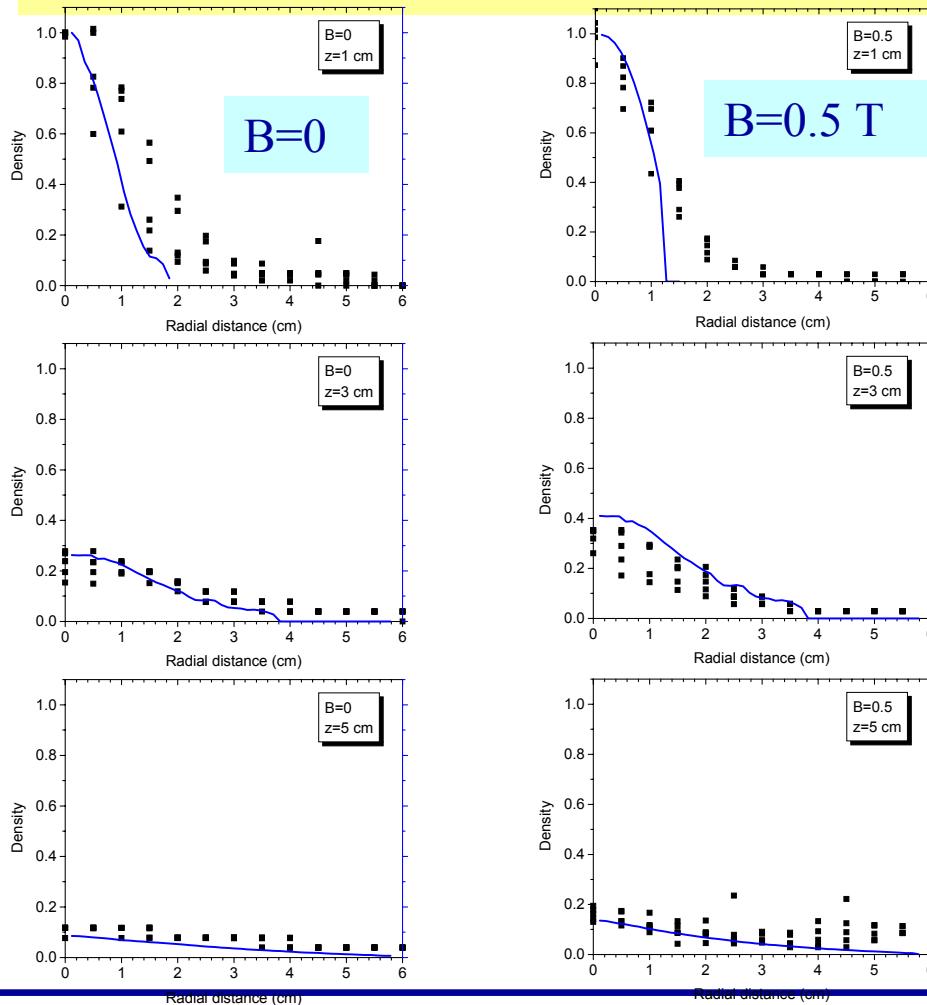




Micro-Vacuum Arc Thruster Plume



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Summary (1)

- Various microthruster technologies based on ablative mechanism were developed

	μ PPT	μ VAT	μ LPT
I_{sp} , s	1000	1000-3000	300-2000
I_{bit} , μ N-s	1-10	1 [0.001-1]	0.001
T/P, μ N/W	~10	2-20	50-100
Dry mass, kg	0.5	0.3	0.5
Flexibility	low	some	high
Experimental data	a lot	some	some
Modeling status	high	some	some



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Summary (2)

- Self-consistent modeling approach for ablative micro-thrusters was formulated based on a kinetic ablation model and particle plume simulation.
- Most extensive validation of the modeling approach was performed for micro-pulsed plasma thruster. Plasma density, surface temperature, ablation rate, ablation profile were compared with experiment. Optimization criteria were formulated for some devices, such as microPPT.



Future needs



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- Development of more flexible technology (variable I_{sp} , variable thrust)
 - μ LPT pulse duration
 - μ VAT pulse duration, material
- Contamination issues
 - Study is needed (μ VAT)
- Lifetime issues (propellant recession)
 - μ VAT, μ PPT
- Hybrid thrusters
 - μ VAT/ μ PPT; μ LPT/ μ PPT
- Modeling: further characterization of thrusters (μ VAT), plumes. Effect of the magnetic field